

<b>Notice of References Cited</b>	Application/Control No. 10/025,601	Applicant(s)/Patent Under Reexamination CHIU ET AL.	
	Examiner Kim-Kwok CHU	Art Unit 2653	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,542,447	04-2003	Matsuo et al.	369/44.23
*	B	US-5,790,504	08-1998	Hayashi et al.	369/112.12
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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